

FIGURE 1

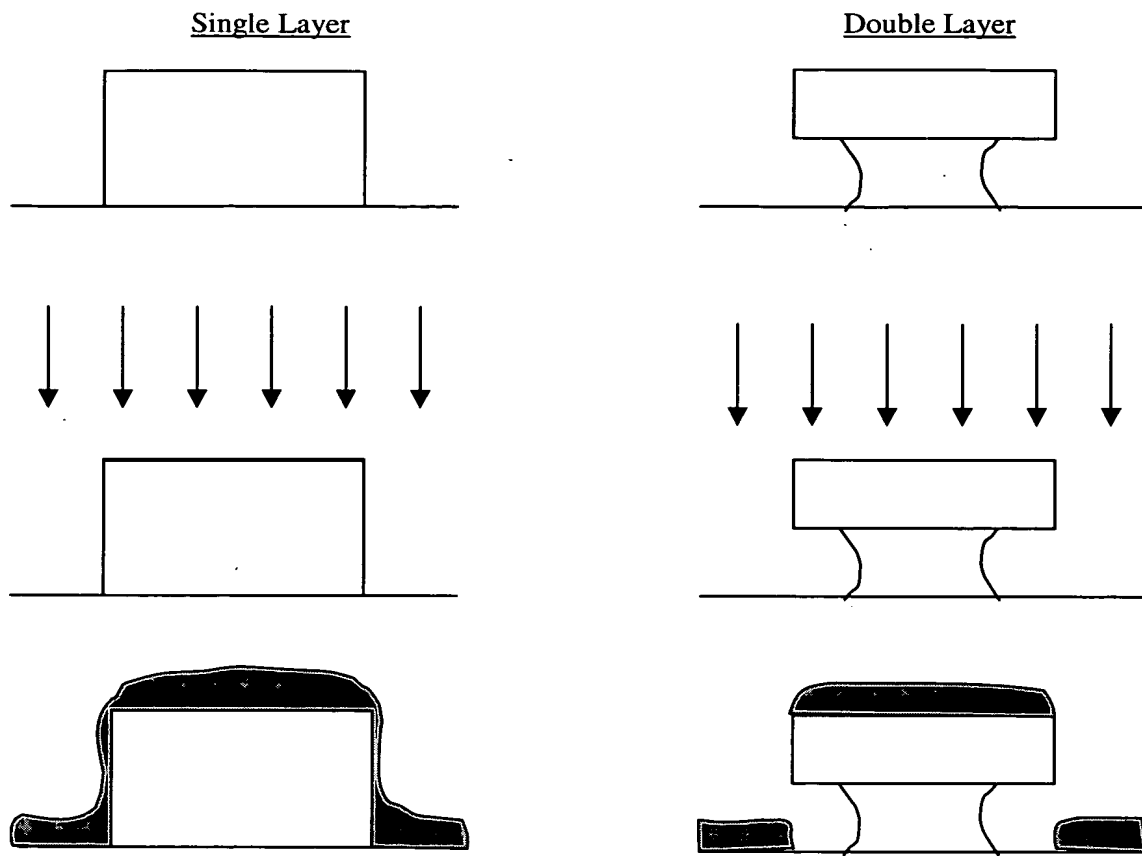


FIGURE 2

SEM of two layered resists after developing

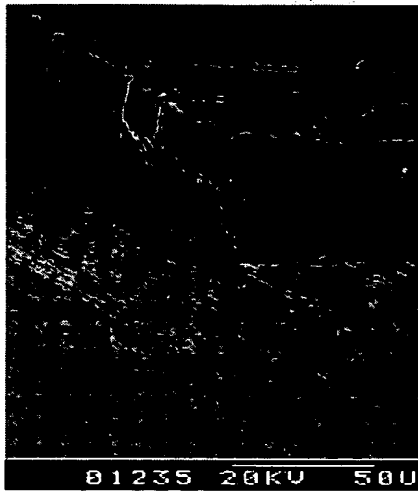


FIGURE 3